



JSW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuko OKADA et al.

Group Art Unit: 1762

Application No.: 10/617,747

Examiner: J. LIN

Filed: July 14, 2003

Docket No.: 109100.01

For: THIN FILM FORMATION METHOD BY INK JET METHOD, INK JET
APPARATUS, PRODUCTION METHOD OF ORGANIC EL DEVICE, AND
ORGANIC EL DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the September 1, 2006 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.